Hazem Mesilhy

Engineer



About me

Passionate engineer specializing in computational lithography, focusing on EUV mask absorber and reflective multilayer modeling. Skilled in diverse programming languages and disciplines. Committed to pushing technological boundaries and finding innovative solutions. Proven track record of exceeding project goals. Eager to contribute to groundbreaking advancements in lithography and beyond.

personal

Hazem Mesilhy nationality: Egyptian 1993

Areas of specialization

Computational Lithography
• Modeling • Programming
• Machine learning

Interests

Programming languages.

Mountain biking.

Skills

Numerical Optimization
/ Machine Learning / Optics
simulation and modeling
Linux / Problem solving
/ Teamwork



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SHORT RESUMÉ

2019-Present

Research Scientist

ERLANGEN · Germany ?

Fraunhofer

Specialize in EUV lithography with a focus on mask/shadowing effects, EUV mask enhancement, absorber, and reflective multilayer modeling. Developed a reliable multilayer degradation model. Participated in European project management, student mentoring, customer presentations, and Dr.LiTHO maintenance.

2017-2019

Research Assistant

ERLANGEN · Germany ?

Fraunhofer

Engaged in first investigations into Hyper-NA EUV (NA of 0.75) feasibility study, while also providing vital support for EUV mask simulations and optimizations across diverse European projects. Participated in debugging, building, and generating installer packages for Dr.LiTHO to ensure smooth customer experiences.

June-Sept. 2015

Intern Programmer

Jaipur · India 💡



Focused on Android development, animation, and widget creation, incorporating machine learning algorithms for efficient unused folder management. Participation in DevOps and the software development cycle, contributing to streamlined server and proxy setup. Customized Chromium and Mozilla browsers for Android using C under Linux environment. Implemented image quality enhancements and filters with OpenCV.

DEGREES

2019

2023 **Ph.D.**

FAU · Erlangen 🏛

Master of Science

FAU · Erlangen 🏦

FAU French Absorber Milwells Disrope Werbers python

C++

Programming

java

Friedrich-Manager-Milwers Erlanger-Mürnberg

2016 Bachelor

FACULTY OF ENGINEERING · Cairo uni m

Best Student Paper Award:

2021 SPIE Photomask Tech-

nology + EUV Lithography

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PUBLICATIONS

More than 17 publications: Google Scholar

LANGUAGES

Awards

Arabic English German C2 mother tongue C2 • • • • • • A2

Talks

Various SPIE conferences and panels. 2022 ASML Technology Conference 2023 ASML Technology Conference